



Atty Docket No.: 0630.0021C

UNITED STATES PATENT AND TRADEMARK OFFICE

In re the PATENT application of

Berry, et al.

Confirmation No.: 6935

Serial No.: 09/505,695

Group Art Unit: 2814

Filed: February 17, 2000

Examiner: Le, Thao X.

For: Method of Photoresist Ash Residue Removal

AMENDMENT

Commissioner for Patents
2900 Crystal Drive
Arlington, Virginia 22202-3513

Sir:

In response to the Office Action of July 11, 2003, please amend the above-identified application as follows.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.



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